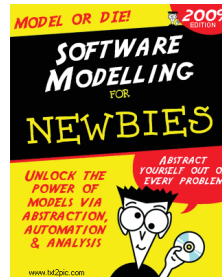


# CISC836: Beyond code: An Introduction to Model-Driven Software Development



## Topic: EMF

- Meta modeling
- Languages for meta models: Ecore
- Using EMF and Ecore to define a data model
- Using EMF to generate code for data model  
⇒ Prep for Xtext

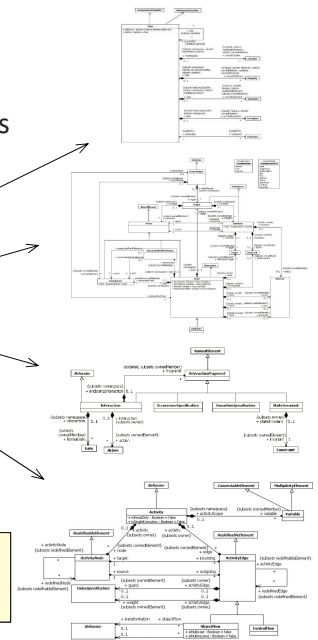
Juergen Dingel  
Feb 2021

## Metamodeling

Can use concepts from Class models/diagrams to describe structure (“abstract syntax”) of modeling concepts in UML:

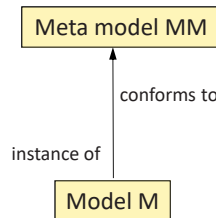
- **Classes:** Section 11.4.2 in [UML2.5](#)
- **Statemachines:** Section 14.2.2
- **Interactions:** Section 17.2.2
- **Activities:** Section 15.2.2
- **Packages:** Section 12.2.2
- **Behaviour**
- **Classification:** Classifiers, Features, Properties, Operations

These class models are **metamodels**, i.e., models describing models

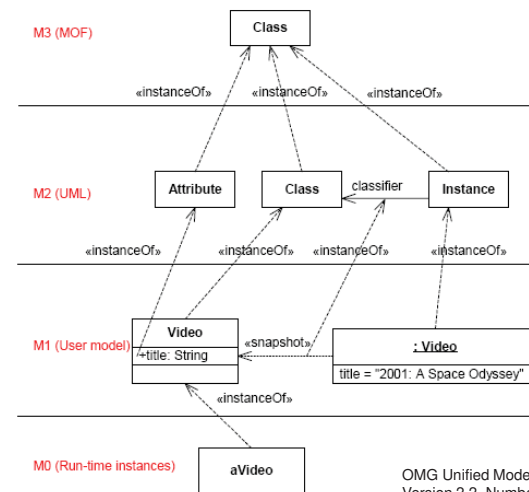


## Metamodeling (Cont'd)

- **Meta model MM:** model (a specification) of a set of models (i.e., a modeling language L(MM))
- **Instance M of meta model MM:** well-formed model in modeling language L (i.e.,  $M \in L(MM)$ )
- **Languages for expressing meta models**
  - **Meta Object Facility (MOF):**
    - OMG standardized language for defining modeling languages
    - **subset of UML class diagrams:** types (classes, primitive, enumeration), generalization, attributes, associations, operations
  - **ECore:**
    - Eclipse version of MOF; used by Xtext
  - **Object Constraint Language (OCL):**
    - declarative language to express well-formedness rules (e.g., “the inheritance hierarchy is acyclic”)



## Metamodeling (Cont'd)

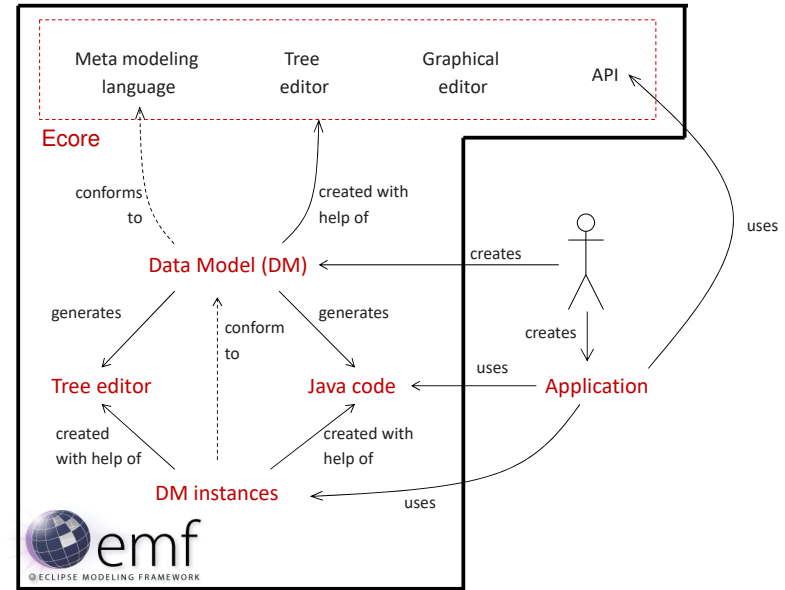


OMG Unified Modeling Language, Infrastructure, Version 2.2. Number: formal/2009-02-04

# Eclipse Modeling Framework

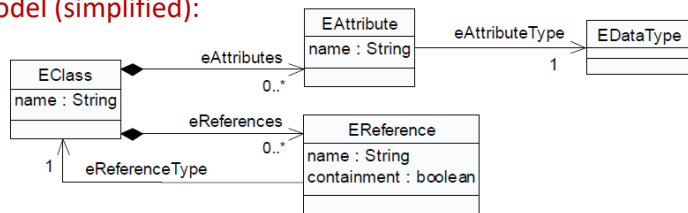


- Eclipse-based open-source framework supporting the development of applications requiring a structured **data model (DM)**
- Consists of
  - **Ecore**
    - **Meta modelling language** for the description of DMs with support for
      - change notification (via the Observer design pattern),
      - persistence (via XML serialization), and
      - generic object manipulation (via reflective API)
  - **EMF.Codegen**
    - Generates code implementing the DM and supporting the development of tools creating and manipulating data model instances:
      - **Model**: Java interfaces and implementation of DM (using Factory design pattern)
      - **Editor**: plugin for tree-based editor of DM instances
      - **Edit**: implementation classes adapting DM classes for editing and display (via Adapter Factory design pattern)
  - **Large user community**: <http://www.eclipse.org/emf>



## Ecore: Metamodeling Language

- **Metamodel (simplified):**



- **EObject**

- Base of every Ecore class and every generated class
- Provides support for **notification** and **persistence**

```

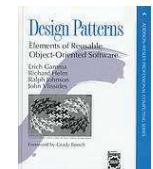
EObject
+eClass(): EClass
+eIsProxy(): boolean
+eResource(): EResource
+eContainer(): EObject
+eContainingFeature(): EStructuralFeature
+eContainmentFeature(): EReference
+eContents(): EEList
+eAllContents(): ETreeIterator
+eCrossReferences(): EEList
+eGet(feature: EStructuralFeature): EJavaObject
+eGet(feature: EStructuralFeature, resolve: boolean): EJavaObject
+eSet(feature: EStructuralFeature, newValue: EJavaObject)
+eIsSet(feature: EStructuralFeature): boolean
+eUnset(feature: EStructuralFeature)
    
```

[Summary of package org.eclipse.emf.ecore]

[Steinberg, Budinsky, Paternostro, Merks. EMF: Eclipse Modeling Framework (2nd Ed.). 2008]

## EMF: Supporting Technology

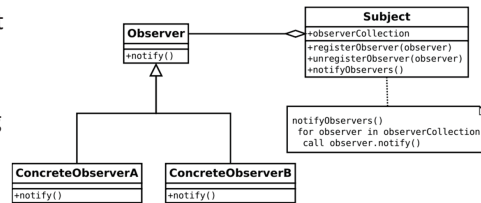
- **Eclipse**
  - Editors are Eclipse plugins
- **Sirius**
  - Framework for automatic generation of graphical editors
- **JUnit**
  - Supported by generated test code
- **Design patterns**
  - Observer
  - Factory
  - Adapter Factory



## Observer Design Pattern

Object, called **subject**, maintains list of its dependents, called **observers**, and **notifies them automatically of any state changes**, usually by calling one of their methods.

Used for **MVC pattern**.



```
import java.util.Observable;
import static java.lang.System.out;

class MyApp {
    public static void main(String[] args) {
        out.println("Enter Text >");
        EventSource eventSource = new EventSource();

        eventSource.addObserver((Observable obj, Object arg) -> {
            out.println("\nReceived response: " + arg);
        });

        new Thread(eventSource).start();
    }
}

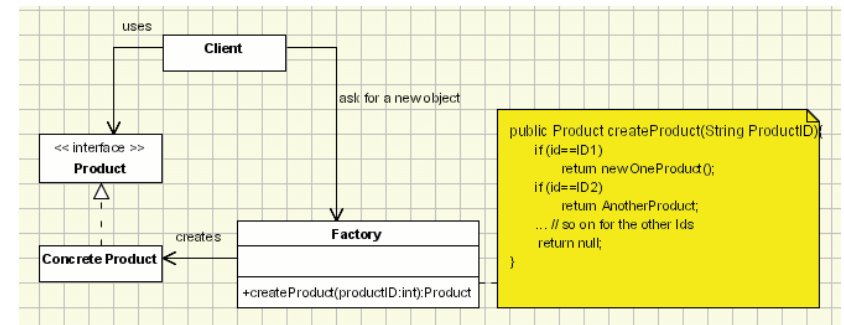
import java.util.Observable;
import java.util.Scanner;

class EventSource extends Observable implements Runnable {
    public void run() {
        while (true) {
            String response = new Scanner(System.in).next();
            setChanged();
            notifyObservers(response);
        }
    }
}
```

[Wikipedia. Observer pattern. [https://en.wikipedia.org/wiki/Observer\\_pattern](https://en.wikipedia.org/wiki/Observer_pattern). 2016]

## Factory Design Pattern

Object, called the **Factory**, encapsulates details of creation of different **Products**

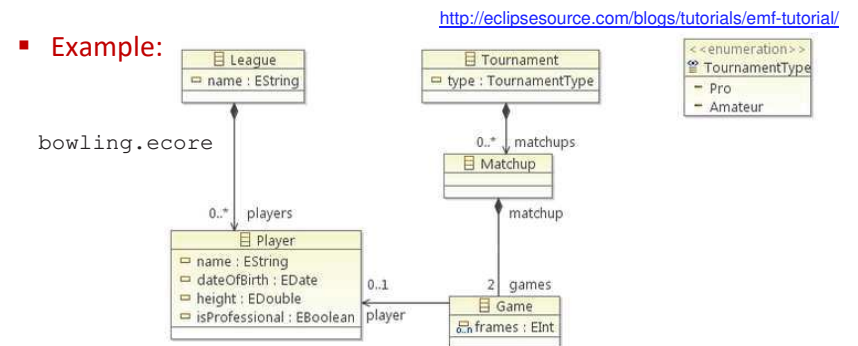


[OODesign.com. Factory pattern. <http://www.oodesign.com/factory-pattern.html>. 2016]

## Using EMF: Getting Started

- Download and installation
  - <http://www.eclipse.org/modeling/emf>
- Documentation
  - <http://www.eclipse.org/modeling/emf/docs/>
- Tutorials
  - <http://www.vogella.com/tutorials/EclipseEMF/article.html>
  - <http://eclipsesource.com/blogs/tutorials/emf-tutorial/>
  - <http://www.philmann-dark.de/EMFDocs/tutorial.html>

## Using EMF: Create Domain Model (DM)

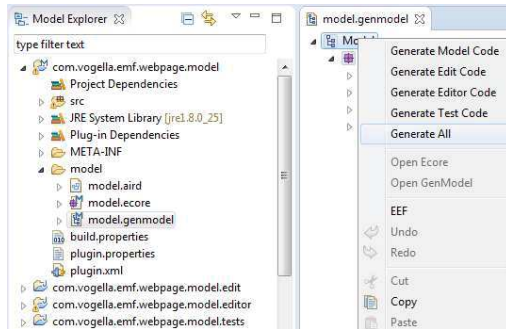


- Root classes: League, Tournament
- Containment relationship b/w Matchup and Game is **bi-directional**
  - “Containment = true” for reference games
  - matchup is opposite of games:
    - for all `m:Matchup`, if `g:Game` in `m.games`, then `g.matchup == m`

## Using EMF: Generate Code from DM

- **Genmodel**
  - Generated from .ecore model
  - Contains additional info necessary for code generation (package names, source paths, project names, generator settings)
  - Automatically synchronized with .ecore model when .ecore model is saved

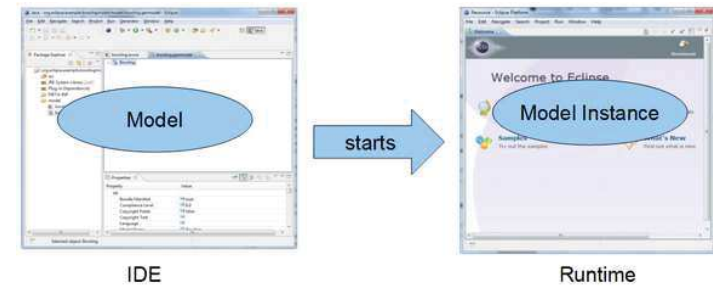
- **To generate:**
  - Open .genmodel
  - right-click root node
  - select plugin to generate



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## Using EMF: Use Generated DM Editor

- Code for DM editor generated as Eclipse plugin
- Invocation of the editor will create another instance of Eclipse in which the editor will execute

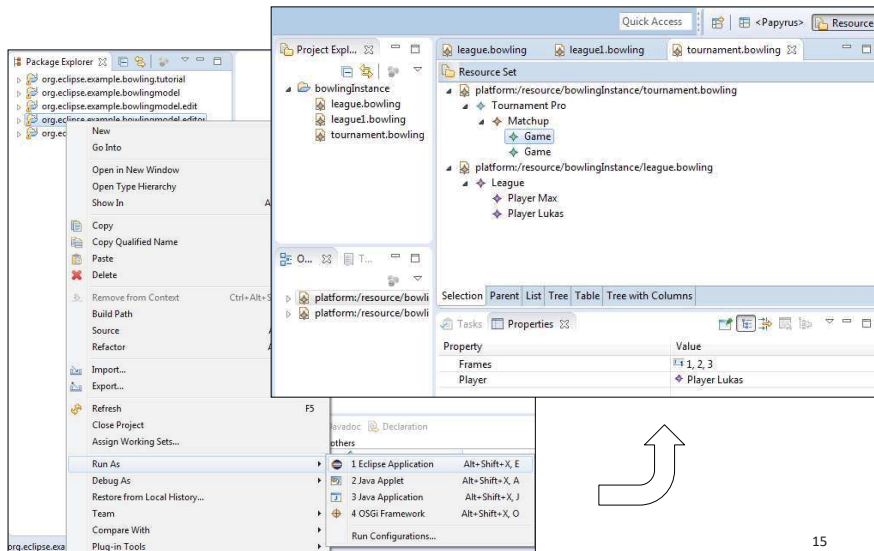


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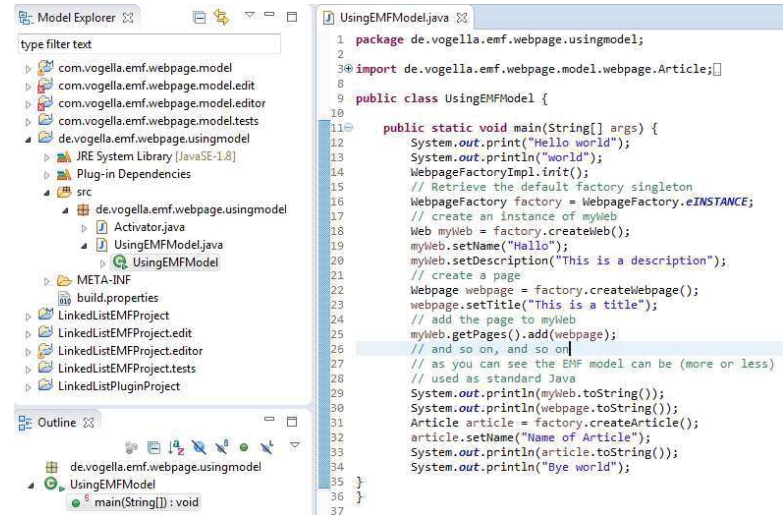
14

## Using EMF: Use Generated DM Editor (Cont'd)



15

## Using EMF: Use Generated DM Java Code



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EMF

16

## Using EMF: Demo

- Using generated test code
- Generating JavaDoc
- Generating method bodies



## EMF: Pros and Cons

- **Pros**
  - Quite powerful, stable, adequate documentation
  - Integral part of Eclipse Modeling ecosystem:
    - EMF Forms: for generation of form-based UI
    - Xtext: for DSL implementation
    - ATL: for model-to-model transformation
- **Cons**
  - Inherit Eclipse “baggage” (but can use Rich Client Platform)

## EMF: More Info

- **Installation**
  - <http://www.eclipse.org/modeling/emf>
- **Documentation**
  - <http://www.eclipse.org/modeling/emf/docs/>
- **Tutorials**
  - <http://eclipsesource.com/blogs/tutorials/emf-tutorial/>
  - <http://www.vogella.com/tutorials/EclipseEMF/article.html>
  - <http://www.philmann-dark.de/EMFDocs/tutorial.html>
- **Book**
  - Steinberg, Budinsky, Paternostro, Merks.  
EMF: Eclipse Modeling Framework (2<sup>nd</sup> Ed.).  
Addison-Wesley Professional. 2008.

